INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 12, 2026

IGI Report Number	LG844668870
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	9.04 X 5.65 X 3.50 MM

GRADING RESULTS

Carat Weight	1.10 CARAT
Color Grade	H
Clarity Grade	VS 1

ADDITIONAL GRADING INFORMATION

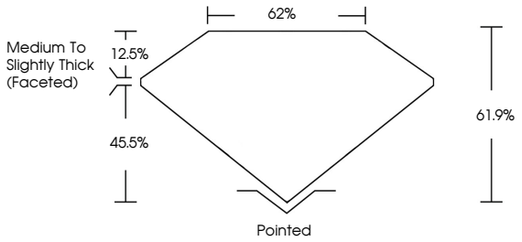
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG844668870

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG844668870

Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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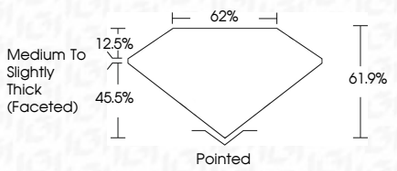
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IGI

October 12, 2026
IGI Report No LG844668870
OVAL BRILLIANT
9.04 X 5.65 X 3.50 MM
Carat Weight 1.10 CARAT
Color Grade H
Clarity Grade VS 1
Depth 61.9%
Table 62%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG844668870
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa